

Application Data Sheet

Application Information

Application number::

Filing Date::

Application Type::

Subject Matter::

Title ::

Regular

Utility

METHOD FOR

MANUFACTURING

SEMICONDUCTOR DEVICE

AND HEAT TREATMENT

METHOD

0756-7201

Attorney Docket Number::

Total Drawing Sheets::

Small Entity?::

13

No

Applicant Information

Applicant Authority Type::

Primary Citizenship Country::

Given Name::

Middle Name::

Family Name::

Name Suffix::

City of Residence::

State or Province of Residence::

Country of Residence::

Inventor

Japan

Toru

TAKAYAMA

Atsugi

Kanagawa

Japan

Street of mailing address:: c/o Semiconductor Energy
Laboratory Co., Ltd., 398,
Hase
City of mailing address:: Atsugi-shi
State or Province of mailing address:: Kanagawa-ken
Country of mailing address:: Japan
Postal or Zip Code of mailing address:: 243-0036

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Japan
Given Name:: Shunpei
Middle Name::
Family Name:: YAMAZAKI
Name Suffix::
City of Residence:: Setagaya
State or Province of Residence:: Tokyo
Country of Residence:: Japan
Street of mailing address:: c/o Semiconductor Energy
Laboratory Co., Ltd., 398,
Hase
City of mailing address:: Atsugi-shi
State or Province of mailing address:: Kanagawa-ken
Country of mailing address:: Japan
Postal or Zip Code of mailing address:: 243-0036

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Japan
Given Name:: Tetsuji

Middle Name::
Family Name:: YAMAGUCHI
Name Suffix::
City of Residence:: Atsugi
State or Province of Residence:: Kanagawa
Country of Residence:: Japan
Street of mailing address:: c/o Semiconductor Energy
Laboratory Co., Ltd., 398,
Hase
City of mailing address:: Atsugi-shi
State or Province of mailing address:: Kanagawa-ken
Country of mailing address:: Japan
Postal or Zip Code of mailing address:: 243-0036

Correspondence Information

Correspondence Customer Number :: 31780
E-Mail address:: erobinson@riplo.com

Representative Information

Representative Customer Number:: 31780

Domestic Priority Information

| Application :: | Continuity Type:: | Parent Application:: | Parent Filing Date:: |
|----------------|-------------------|----------------------|----------------------|
| | | | |
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| | | | |

Foreign Priority Information

| Country:: | Application number:: | Filing Date:: | Priority Claimed:: |
|-----------|----------------------|---------------|--------------------|
| Japan | 2002-276402 | 09/20/2002 | Yes |

Assignee Information

| | |
|---|--|
| Assignee name:: | Semiconductor Energy Laboratory Co., Ltd. |
| Street of mailing address:: | 398 Hase |
| City of mailing address:: | Atsugi-shi |
| State or Province of mailing address:: | Kangawa-ken |
| Country of mailing address:: | Japan |
| Postal or Zip Code of mailing address:: | 243-0036 |